



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kenji YONEDA

Application No.: 10/822,722

Filed: April 13, 2004

Customer Number: 20277

Confirmation Number: 2871

Group Art Unit: 2891

Examiner: Everhart, Caridad

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR SUBSTRATE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

| | NO. OF CLAIMS | HIGHEST PREVIOUSLY PAID FOR | EXTRA CLAIMS | RATE | FEE |
|---|------------------|-----------------------------------|-----------------|------------|--------|
| Total Claims | 5 | 20 | 0 | \$50.00 = | \$0.00 |
| Independent Claims | 5 | 6 | 0 | \$200.00 = | \$0.00 |
| Multiple dependent claims newly presented | | | | | \$0.00 |
| Fee for extension of time | | | | | \$0.00 |
| | | | | | \$0.00 |
| Total of Above Calculations | | | | | \$0.00 |

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty
Registration No. 36,139

Please recognize our Customer No. 20277 as our
correspondence address.

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Date: February 13, 2006



Docket No.: 060188-0834

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|--|---|-----------------------------|
| In re Application of | : | Customer Number: 20277 |
| Kenji YONEDA | : | Confirmation Number: 2871 |
| Application No.: 10/822,722 | : | Group Art Unit: 2891 |
| Filed: April 13, 2004 | : | Examiner: Everhart, Caridad |
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AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 15, 2005, having a three-month shortened statutory period for response set to expire February 15, 2006, please amend the above-identified application as follows.